

10/540637

JUN 23 2005 Rec'd PCT/PTO

FORM PTO-1449/A and B (Modified) INFORMATION DISCLOSURE STATEMENT BY APPLICANT				APPLICATION NO.: Not yet assigned	ATTY. DOCKET NO.: S1459.70074US00
				FILING DATE: Herewith	CONFIRMATION NO.: Not yet assigned
				APPLICANT: Koji Kadono et al.	
				GROUP ART UNIT: Not yet assigned	EXAMINER: Not yet assigned
Sheet	1	of	1		

U.S. PATENT DOCUMENTS

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		

FOREIGN PATENT DOCUMENTS

Examiner's Initials	Cite No.	Foreign Patent Document			Name of Patentee or Applicant of Cited Document (not necessary)	Date of Publication of Cited Document MM-DD-YYYY	Translation (Y/N)
		Office/ Country	Number	Kind Code			
/MW/	1	PCT	WO00/19494	A1	Xidex Corporation	04-06-2004	Y
/MW/	2	Japan	JP05-205615	A		08-13-1993	N
/MW/	3	Japan	JP2003-146632	A		05-21-2003	N

OTHER ART — NON PATENT LITERATURE DOCUMENTS

Examiner's Initials	Cite No	Include name of the author (in CAPITAL LETTERS) title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, relevant page(s), volume-issue number(s), publisher, city and/or country where published.	Translation (Y/N)
/MW/	4	MATSUI, S. et al., "Three-dimensional nanostructure fabrication by focused-ion-beam chemical vapor deposition," J. Vac. Sci. Technol. B, Vol. 18, No. 6, 2000, pp. 3181-3184 , Nov/Dec 2000.	

EXAMINER:

/Mary Wilczewski/

DATE CONSIDERED:

03/16/2009

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*a copy of this reference is not provided as it was previously cited by or submitted to the office in a prior application, Serial No. __, filed __, and relied upon for an earlier filing date under 35 U.S.C. 120 (continuation, continuation-in-part, and divisional applications).

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